

Notice of References Cited	Application/Control No. 10/044,271	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Stephen J. Stein	Art Unit 1775	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0123167 A1	07-2003	Kolberg et al.	359/885
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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